



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re application of : Confirmation No. 4423
Tomohiro OKUMURA et al. : Docket No. 2001_1089A
Serial No. 09/918,823 : Group Art Unit 2821
Filed August 1, 2001 : Examiner T. Phan

PLASMA PROCESSING METHOD
AND APPARATUS THEREOF

AMENDMENT

Assistant Commissioner for Patents,
Washington, D.C.

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action mailed August 28, 2002, a three month extension of time having been obtained, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Please replace the specification with the attached substitute specification.

IN THE ABSTRACT:

Please replace the abstract with the attached substitute abstract.

MAR - 5 2003
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